

The VSiPMT project: characterization of the second generation of prototypes TIPP 2017 - International Conference on Technology and Instrumentation in Particle Physics Beijing, People's Republic of China – May 22-26, 2017

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Outline



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- The EB-MPPC100 prototype
- Characterization:
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 - \circ photon spectra
 - \circ dark noise
 - o gain
 - \circ efficiency
 - \circ focusing
 - \circ linearity
 - \circ timing
 - $\circ~$ photocathode homogeneity
- Conclusions and perspectives

Beyond PMTs

- fluctuations in the first dynode gain → single photon counting difficult;
- linearity strongly related to the gain (decreases as gain increases);
- transit time spreads over large fluctuations;
- complex and expensive mechanical structure;
- sensitivity to magnetic fields;
- need of voltage dividers
 power consumption and failure risks increase.



New generation of semiconductor photodetectors, based on inverse p-n junction:

- PIN photodiodes: no gain;
- avalanche photodiodes (APD): gain of few hundreds;
- avalanche photodiodes in linear Geiger-mode (GM-APD, or SiPM): gain of 10⁵ – 10⁶.





An innovative design for a modern hybrid photodetector based on the combination of a Silicon PhotoMultiplier (SiPM) with a Vacuum PMT standard envelope



The classical dynode chain of a PMT is replaced with a SiPM, acting as an electron multiplying detector.

Expected advantages

Window

Dynodes

Voltage Dropping Resistors Anode

Power Supply

Incoming Photon

Photo-

cathode

Focusing Electrode



Unprecedented features:

- Photon counting capability;
- Low power consumption;
- Large sensitive surface;
- Excellent timing performances (low TTS);
- High stability (not depending on HV).



Multiplication gain (series) Energy resolution $\alpha 1/(d^{1st})^{-1/2}$ G=dⁿ=(kV_d)ⁿ





"Parallel" gain (digital) no statistic fluctuations

• Time resolution

$$\sigma_{\text{total}}^{2} = \sigma_{\text{pc}_{em}}^{2} + \sigma_{em}^{2}$$

$$\sigma_{\text{pc}_{em}} \alpha (V_{\text{pc}_{em}})^{-1/2}$$

$$\sigma_{em} \alpha (d^{1\text{st}})^{-1/2}$$

 $\sigma^{2}_{\text{total}} = \sigma^{2}_{\text{pc em}} + \sigma^{2}_{\text{em}}$

• Gain stabilization

 $dG/G=n dV_d/V_d=n dV_b/V_b$

easy, low voltage



The VSiPMT follows a technology path **pioneered by HAPDs**

Both hybrid photodetectors, based on the combination of photocatdode and semicon. technologies. Anyway...

In a HAPD bombardment gain is required

APD drawbacks;

- G=E_{phe}/E_{e,h}≈10⁴-10⁵
- too low Gain. HV gain required
- G depending on HV
- Need a strong HV critical stabilization
- Difficult and expensive insulation



In a VSiPMT the gain is made by the amplification stage only, as for **PMTs**.

VSiPMT advantages:

- **G > 10**⁶: a factor 10 higher.
- Low HV, no need for bombardment gain
- Low voltage Gain: easy to stabilize
- Normal insulation



Timeline



NIC







8

Dimensional outlines







Specifications

Param	neter	Value	Unit
Spectral Response		200 to 650	nm
Photocathode	Material	Bialkali	-
	Effective Area	Φ22	mm
Window Material		Borosilicate Glass	-
Target		MPPC 3x3 mm	-

Maximum Ratings (Absolute Maximum Values)

Parameter	Value	Unit
Photocathode Voltage	-2000	V dc
MPPC Reverse Bias Voltage at 25°C	+72.0	V dc

Experimental setup



22/05/17







Photon spectra

Title



- Excellent photon counting capability!
- Dark noise and gain exhibit no significative difference between HV on (-1.9kV) and HV off





22/05/17

Phenomenology



photoelectrons from photocathode

1. photoelectron with not enough energy to

- enter in depletion region (p⁺n) and to trigger Geiger avalanche.
- photoelectron with very marginal energy to enter in depletion region (p⁺n) and to trigger Geiger avalanche.
- photoelectron with enough energy to enter in depletion region (p⁺n) and to trigger Geiger avalanche.

Definition

- $\varepsilon_{photocathode}$ = photocathode efficiency (fixed number @fixed λ)
- $\epsilon_{\text{fill-factor-SiPM}}$ = geometrical efficiency (fixed number)
- ε_{trigger} = trigger efficiency (depends on the High Voltage)
- $\varepsilon_{\text{focusing}}$ = focusing efficiency

When the high voltage gives to all the photoelectrons enough energy to penetrate inside the p-region of the SiPM, the behaviour of $\varepsilon_{trigger}$ as a function of high voltage becomes flat (plateau $\varepsilon_{trigger}$ =1) and the total efficiency will be a fixed number (@fixed λ).



150 nm passivation layer

Simulations

Range and **energy deposit** of the photoelectrons in the SiPM as a function of SiO₂ passivation layer thickness have been simulated (range: 150 to 15nm).

Assumption: the average energy of photoelectrons outcoming from the photocathode is 1 eV.

100 nm passivation layer

15 nm passivation layer



Simulations show that the HV to have $\varepsilon_{trigger}$ =1 rises with the passivation layer thickness.

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VSiPMT



Focusing efficiency (and linearity, as well) are maximized if in a condition of uniformly illuminated photocathode all the SiPM pixels are hit by the accelerated photoelectrons.



 If the photoelectron spot is larger than the SiPM size, some photoelectron will systematically miss the target → focusing efficiency < 1

 On the other side, if the photoelectron beam is too much "squeezed", the focusing efficiency will still be 1 but the device will lose linearity



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Ζ				~	1	$\mathbf{\Lambda}$
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Even in the ideal case, the SiPM pixels that are not involved in the detection process are still contributing to dark noise!

One step back







Efficiency is highly stable over 3200 V. No need for high voltage stabilization.

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Photocathode





Assuming a plateau region working regime and an optimized focusing $\varepsilon_{total}(PDE) = \varepsilon_{photocathode} \times \varepsilon_{fill-factor-SiPM} \times \varepsilon_{trigger} \times \varepsilon_{focusing}$ $0,09 = 0,12 \times 0,78 \times 1 \times 1$

- The maximum PDE measured for the prototype is $\approx 2\%$
- The plateau region is not reached!

Reason: maximum rating for PMT HV is -2kV! (insulation issue)

$$\varepsilon_{\text{total}}(\text{PDE}) = \varepsilon_{\text{photocathode}} \times \varepsilon_{\text{fill-factor-SiPM}} \times \varepsilon_{\text{trigger}} \times \varepsilon_{\text{focusing}}$$

$$0,02 = 0,12 \times 0,78 \times ? \times ?$$



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Focusing



No clue about the characteristics of the SiPM inside the prototype.

Measurement of focusing efficiency is done as follows:

- the photocathode is illuminated with high photon number.
- Under this condition, the SiPM is saturated.
- Number of maximum fired cells is calculated as:

max fired cells = $\frac{Q (total MPPC charge collected)}{Q (single MPPC charge)}$

Results: max fired cells = 900 ± 15 over a total MPPC cells = 900



Radius of photoelectron focusing area circumscribes the MPPC square shape or is outside the square. The system is UNDERFOCUSED.

Not possible to say how much! $\varepsilon_{focusing} < 1$





The linearity curve of a SiPM follows the well-known formula:

$$Nfired = Ntotal \times \left[1 - exp\left(\frac{-Nphoton \times PDE}{Ntotal}\right)\right]$$
From the linear fit:
$$Ntotal (max fired cells) = (9.40 \pm 1.0) \times 10^{2}$$

$$PDE = (2.77 \pm 0.12) \%$$
in quite good agreement with the measured PDE
$$UNDERFOCUSED system$$

$$(\varepsilon_{focusing} < 1)$$
A well-focused devise would have Ntotal (max fired cells) ≈ 700

700

0

N Cells Fired 2009 2009 2009

400

300

200

100





- The output from the VSiPMT is fed as the • stop signal via a discriminator;
- We measure the time interval between the "start" and "stop" signals.

67765

Dt (ns)

6.205e-08





projection of 3x3 the SiPM on the photocathode obtained by direct photon detection when H.V. is off 4% of over-efficiency for photon transparency only at center of photocathode. Negligible effect in all usual photodetection applications

Projection:

optimized device (photocathode QE \approx 30%, $\varepsilon_{\text{focusing}}$ =1) =27.4% ε=30% +4% 23,4% 23,4% 23,4% 8 tot. Photocathode surface SiPM ε=**78% Quantitative effect:** +4% of over-efficiency in 1,7% of total 1 inch photocathode surface area **2** inch photocathode: less and less effect

VSiPMT



The aim of the EB-MPPC100 1INCH prototype is the proof of feasibility of an inch-size VSiPMT. Results are excellent!

The device exhibits outstanding features:

- Excellent photon counting capability
- Large sensitive surface (first inch-size prototype)
- Challenging time performances
- Major limit: High Voltage limited to 2000 Volt. The drawback is the low efficiency. The energy inferred by HV to the photoelectrons is not enough to overcome the SiPM entrance window and to penetrate in the p-region of the SiPM (absence of a plateau in the efficiency plot). Consequently, also stability is affected.
- Also the underfocusing of the photoelectrons could be improved by a better spatial positioning of the SiPM. Undramatic: easy to solve (not optimized device).



An optimized insulation or an improved design can help to bring the HV at the correct point, thus allowing to work in the PDE plateau region and so at the maximum efficiency.

Ready for the next step!